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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
09/649,528	08/28/2000	Chowdary Ramesh Koripella	CT00-013	8469

23330 7590 05/31/2005

MOTOROLA, INC.
LAW DEPARTMENT
1303 E. ALGONQUIN ROAD
SCHAUMBURG, IL 60196

EXAMINER

LEUNG, JENNIFER A

ART UNIT	PAPER NUMBER
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1764

DATE MAILED: 05/31/2005

Please find below and/or attached an Office communication concerning this application or proceeding.

Office Action Summary

Application No.

09/649,528

Applicant(s)

KORIPPELLA ET AL.

Examiner

Jennifer A. Leung

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-- The MAILING DATE of this communication appears on the cover sheet with the correspondence address --

Period for Reply

A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) FROM THE MAILING DATE OF THIS COMMUNICATION.

- Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication.
- If the period for reply specified above is less than thirty (30) days, a reply within the statutory minimum of thirty (30) days will be considered timely.
- If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication.
- Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133). Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b).

Status

- 1) ☒ Responsive to communication(s) filed on 18 March 2005.
- 2a) ☐ This action is FINAL. 2b) ☒ This action is non-final.
- 3) ☐ Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under *Ex parte Quayle*, 1935 C.D. 11, 453 O.G. 213.

Disposition of Claims

- 4) ☒ Claim(s) 1,8,10,11,16 and 18 is/are pending in the application.
- 4a) Of the above claim(s) _____ is/are withdrawn from consideration.
- 5) ☐ Claim(s) _____ is/are allowed.
- 6) ☒ Claim(s) 1,8,10,11,16 and 18 is/are rejected.
- 7) ☐ Claim(s) _____ is/are objected to.
- 8) ☐ Claim(s) _____ are subject to restriction and/or election requirement.

Application Papers

- 9) ☐ The specification is objected to by the Examiner.
- 10) ☐ The drawing(s) filed on _____ is/are: a) ☐ accepted or b) ☐ objected to by the Examiner.
Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).
Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).
- 11) ☐ The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.

Priority under 35 U.S.C. § 119

- 12) ☐ Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).
- a) ☐ All b) ☐ Some * c) ☐ None of:
1. ☐ Certified copies of the priority documents have been received.
 2. ☐ Certified copies of the priority documents have been received in Application No. _____.
 3. ☐ Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)).

* See the attached detailed Office action for a list of the certified copies not received.

Attachment(s)

- | | |
|--|---|
| 1) <input type="checkbox"/> Notice of References Cited (PTO-892) | 4) <input type="checkbox"/> Interview Summary (PTO-413)
Paper No(s)/Mail Date. _____ |
| 2) <input type="checkbox"/> Notice of Draftsperson's Patent Drawing Review (PTO-948) | 5) <input type="checkbox"/> Notice of Informal Patent Application (PTO-152) |
| 3) <input type="checkbox"/> Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08)
Paper No(s)/Mail Date _____ | 6) <input type="checkbox"/> Other: _____ |

DETAILED ACTION

Response to Amendment

1. Applicant's amendment submitted on March 18, 2005 has been received and carefully considered. Claims 2-7, 9, 12-15, 17, 19-21 are cancelled. Claims 1, 8, 10, 11, 16 and 18 are active.

Claim Rejections - 35 USC § 102

The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless –

(b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.

2. Claims 1, 8, 10, 11, 16 and 18 are rejected under 35 U.S.C. 102(b) as being anticipated by Furuya et al. (JP 06-111838).

Regarding claims 1, 8 and 10, Furuya et al. (see Figures, Abstract, and Machine Translation) discloses a hydrogen generator comprising:
a reaction zone including a reforming catalyst (i.e., plate 1, containing reforming catalyst 6; FIG. 1, 2; sections [0010]-[0014]) and a vaporization zone receiving liquid fuel and comprising at least one vapor channel for transporting a vapor from the vaporization zone to the reaction zone (i.e., plate 1 inherently comprises a vaporization zone and vapor channels as defined by flow paths 3, as evidenced by the disclosed evaporation of the “poured” methanol and water within the fuel processor; see Example 1; sections [0060], [0062]); wherein the vaporization and reaction zones comprise a plurality of parallel channels (i.e., passages 3 in plates 1; FIG. 1, 2);

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an inlet channel for introducing liquid fuel into the vaporization zone (as shown in FIG. 7, via a fluid supply hole 27 to a plate 22 containing reforming catalyst in flow paths 23, wherein plate 22 and plate 1 are the same element having different reference numerals; see sections [0034]-[0037]; Also, as schematically shown in FIG. 18, labeled as “MeOH+H₂O”, supplied to hole “d”); and

an outlet channel for transporting hydrogen enriched gas out of the reaction zone (In FIG. 7, a corresponding discharge hole, not drawn, located in plate 22 downstream of hole 27 and flow paths 23, wherein plate 22 and plate 1 are the same element having different reference numerals; see sections [0034]-[0037]; Also, as schematically shown in FIG. 18, labeled as “H₂+CO₂+CO+H₂O+MeOH”, discharged via hole “h”).

The apparatus further comprises a chemical heater including a catalyst (i.e., plates 2 including a combustion catalyst 5 coated on passages 4; sections [0010]-[0016]; FIG. 1, 2) thermally coupled to the reaction and vaporization zones (i.e., reforming plates 1; FIG. 1, 2) using thermally conductive channels or vias (i.e., walls defining combustion passages 4). As schematically shown in FIG. 18, the chemical heater, now labeled as flat plate 121, further comprises an air inlet for receiving oxygen for the oxidation of the fuel (i.e., labeled as the Japanese character for air, supplied to hole “e”; see sections [0085]-[0086]) and an inlet channel for providing fuel to the chemical heater (i.e., labeled as “H₂/MeOH”, supplied to hole “f”). The inlet channel, the vaporization zone, the reaction zone, the at least one vapor channel, the outlet channel and the chemical heater all comprise a fuel processor and all are formed within an integral, sintered, monolithic ceramic carrier (best seen in FIG. 7; plates 1, 2 comprise materials having high thermal conductivity, including sintered ceramic; FIG. 1, 2; sections [0017], [0030]-[0033]).

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Although FIG. 18 schematically shows the inlet channel for providing fuel to the chemical heater (i.e., via hole "f") being separate from the inlet channel for providing fuel to the vaporization zone (i.e., via hole "d"), FIG. 15 further illustrates that the fuel supply paths are actually connected, wherein the inlet channel for supplying fuel to the vaporization zone comprises an opening to further provide fuel to the chemical heater (i.e., fuel from a single tank 41 supplies fuel to both the vaporization zone/reaction zone and the chemical heater, within reforming machine 42, via passages 43 and 44, respectively; see sections [0072]-[0077]; see also FIG. 9).

Regarding claims 11 and 16, Furuya et al. (see Figures, Abstract, and JPO Machine Translation) disclose an apparatus comprising:

a three-dimensional integral, sintered, monolithic multi-layer ceramic carrier structure (i.e., plates 1, 2 comprising materials having high thermal conductivity, including sintered ceramic; FIG. 1, 2; sections [0017], [0030]-[0033]), the carrier structure further defining a fuel processor (i.e., a reforming machine 42, comprising plates 1 and 2; FIG. 8, 15; sections [0040]-[0043]; [0074]-[0077]) having a reaction zone including a reforming catalyst (i.e., reforming catalyst 6 of plate 1; FIG. 1, 2; sections [0010]-[0014]) and inherently comprising a vaporization zone, as evidenced by the disclosed evaporation of the "poured" methanol and water within the fuel processor (i.e., Example 1; sections [0060], [0062]);

the vaporization and the reaction zones comprising a plurality of parallel channels formed in the ceramic carrier for transporting a liquid fuel to the vaporization zone and a vapor in the reaction zone (i.e., passages 3 in plates 1; FIG. 1, 2; Example 1);

the ceramic carrier further comprising an integrated heater (i.e., combustion plates 2) thermally

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coupled to the reaction and vaporization zones using thermally conductive channels or thermally conductive vias (i.e., thermally conductive passages **4**; FIG. 1, 2; sections [0010]-[0016]); and

an outlet channel for transporting hydrogen enriched gas out of the fuel processor (In FIG. 7, a corresponding discharge hole, not drawn, located in plate **22** downstream of hole **27** and flow paths **23**, wherein plate **22** and plate **1** are the same element having different reference numerals; see sections [0034]-[0037]).

The integrated heater is in the form of a chemical heater including a catalyst and arranged to oxidize fuel (i.e., plates **2** including a combustion catalyst **5** coated on passages **4**; sections [0010]-[0016]). As schematically shown in FIG. 18, the apparatus further comprises an inlet channel (i.e., labeled as "H₂/MeOH", supplied to hole "f"), wherein the chemical heater (i.e., now labeled as flat plate **121**, containing the combustion catalyst; see sections [0085]-[0086]) receives fuel from the inlet channel and includes an air port for receiving oxygen for the oxidation of the fuel (i.e., labeled as the Japanese character for air, supplied to hole "e"). The vaporization zone, the reaction zone, the plurality of parallel channels, the chemical heater, the inlet channel and the outlet channel are each formed within the integral, sintered, monolithic ceramic carrier (best seen in FIG. 7).

Regarding claim 18, Furuya et al. (see Figures, Abstract, and JPO Machine Translation) disclose an apparatus comprising:

a three-dimensional integral, sintered, monolithic multi-layer ceramic carrier structure (i.e., plates **1**, **2** comprising materials having high thermal conductivity, including sintered ceramic; FIG. 1, 2; sections [0017], [0030]-[0033]), the carrier structure further defining

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a fuel processor (i.e., a reforming machine **42**, comprising plates **1** and **2**; FIG. 8, 15; sections [0040]-[0043]; [0074]-[0077]) having a reaction zone including a reforming catalyst (i.e., reforming catalyst **6** of plate **1**; FIG. 1, 2; sections [0010]-[0014]) and inherently comprising a vaporization zone, as evidenced by the disclosed evaporation of “poured” methanol within the fuel processor (i.e., Example 1; sections [0060]); the vaporization and the reaction zones comprising a plurality of parallel channels formed in the ceramic carrier for transporting a liquid fuel to the vaporization zone and a vapor in the reaction zone (i.e., passages **3** in plates **1**; FIG. 1, 2; Example 1); the ceramic carrier further comprising an integrated heater (i.e., combustion plates **2**; FIG. 1, 2) thermally coupled to the reaction and vaporization zones (i.e., reforming plates **1**; FIG. 1, 2) using thermally conductive structures (i.e., walls defining combustion passages **4**); and an outlet channel for transporting hydrogen out of the fuel processor (In FIG. 7, a corresponding discharge hole, not drawn, located in plate **22** downstream of hole **27** and flow paths **23**, wherein plate **22** and plate **1** are the same element having different reference numerals; see sections [0034]-[0037]).

The integrated heater is in the form of a chemical heater including a catalyst and arranged to oxidize fuel (i.e., plates **2** including a combustion catalyst **5** coated on passages **4**; sections [0010]-[0016]). As schematically shown in FIG. 18, the chemical heater (i.e., now labeled as flat plate **121**, containing the combustion catalyst; see sections [0085]-[0086]) further comprises an air port for providing oxygen for the oxidation of the fuel (i.e., labeled as the Japanese character for air, supplied to hole “e”) and an inlet channel having an opening to provide fuel to the chemical heater (i.e., labeled as “H₂/MeOH”, supplied to hole “f”). The vaporization zone, the

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reaction zone, the plurality of parallel channels, the chemical heater, the inlet channel and the outlet channel are each formed within the integral, sintered, monolithic ceramic carrier (best seen in FIG. 7).

Instant claims 1, 8, 10, 11, 16 and 18 structurally read on the apparatus of Furuya et al.

Allowable Subject Matter

3. The indicated allowability of previous claims 6, 14 and 21, which subject matter has been at least partially incorporated into instant claims 1, 11 and 18, is withdrawn in view of a different interpretation of the previously applied reference. It is further noted that the subject matter of previous claim 14 was only partially incorporated into claim 11, since claim 14 required the integrated heater to be a chemical heater (i.e., in contrast, instant claim 11 recites that the integrated may comprise a resistive heater *or* a chemical heater), and further required the inlet channel to the vaporization zone to include an opening to provide fuel to the chemical heater (i.e., in contrast, instant claim 11 eliminates the inlet channel to the vaporizer and recites only an inlet channel to the chemical heater). Similarly, the subject matter of previous claim 21 was only partially incorporated into claim 18, since claim 21 required the integrated heater to be a chemical heater (i.e., in contrast, instant claim 18 recites that the integrated may comprise a resistive heater *or optionally*, a chemical heater), and further required the inlet channel to the vaporization zone to include an opening to provide fuel to the chemical heater (i.e., in contrast, instant claim 18 eliminates the inlet channel to the vaporizer and recites only an inlet channel to the optional chemical heater). In addition, the subject matter of previous claim 6 was only partially incorporated into claim 1, since claim 6 required the inlet channel to include an opening to provide fuel to the chemical heater, but no such opening is recited in instant claim.

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Response to Arguments


4. Applicant's arguments with respect to claims 1, 8, 10, 11, 16 and 18 have been considered but are moot in view of the new ground(s) of rejection.

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Jennifer A. Leung whose telephone number is (571) 272-1449. The examiner can normally be reached on 8:30 am - 5:30 pm M-F, every other Friday off.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Glenn A. Caldarola can be reached on (571) 272-1444. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see <http://pair-direct.uspto.gov>. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Jennifer A. Leung
May 26, 2005 


HIEN TRAN
PRIMARY EXAMINER